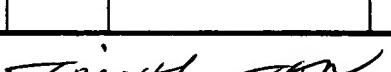
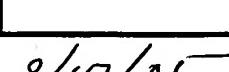


INFORMATION DISCLOSURE STATEMENT BY APPLICANT <small>NOV 03 2004</small>				Complete if Known	
				Application Number	09/513,998
				Filing Date	February 23, 2000
				First Named Inventor	Richard J. Helferich
				Group Art Unit	2684
				Examiner Name	Tan H. Trinh
RECEIVED <small>NOV 05 2004</small> <u>Technology Center 2600</u>					
Sheet	1	of	1	Attorney Docket Number	
0101-140					

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Initials ¹	Cite No. ¹	Foreign Patent Document				Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T ⁶
		Office ³ Code	Number ⁴	Kind ⁵ (if known)				
	A	KR	00164369	I	B1	Samsung Electronics Co., Ltd.	September 11, 1998	✓ AB
	B	JP	06318899	I	A	Dokomo Eng KK Tanaka Masanori	November 15, 1994	✓ AB
Examiner Signature						Date Considered		

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code. ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.